Application No.: 10/683,872 Amendment dated: March 27, 2007

Reply to Office Action of December 27, 2006

Attorney Docket No.: 0002.0004US1

This listing of claims will replace all prior versions and listings of claims in this application:

b.) Listing of Claims

- 1. (Cancelled)
- 2. (Cancelled)
- 3. (Cancelled)
- 4. (Cancelled)
- 5. (Cancelled)
- 6. (Cancelled)
- 7. (Previously presented) An optical system as claimed in claim 9, wherein the ultraviolet radiation has a wavelength of 13 to 14 nanometers and the objective comprises a zone plate made from molybdenum (Mo), niobium (Nb), Technetium (Tc), or Ruthenium (Ru).
- 8. (Cancelled)
- 9. (Currently amended) An optical system comprising:
 - an extreme ultraviolet radiation source;
 - a spectral filter that filters ultraviolet radiation generated by the source;
 - a reflective condenser that directs the ultraviolet radiation onto a target sample

at an angle of between normal to the sample and 7 degrees off normal;

- an aperture for spatially filtering the ultraviolet radiation;
- an objective lens that forms an image of the ultraviolet radiation from the

target sample; and

a spatially resolved detector for detecting the image <u>of the sample</u> formed by the objective lens.

Application No.: 10/683,872

Amendment dated: March 27, 2007

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Attorney Docket No.: 0002.0004US1

10. (Original) An optical system as claimed in claim 9, wherein the source is a

laser-plasma source.

11. (Original) An optical system as claimed in claim 9, wherein the source is a

gas discharge source.

12. (Previously presented) An optical system as claimed in claim 9, wherein the

spectral filter is a multilayer notch filter.

13. (Original) An optical system as claimed in claim 9, wherein the condenser is

a multilayer coated spherical surface.

14. (Currently amended) An optical system comprising:

an extreme ultraviolet radiation source;

a spectral filter that filters ultraviolet radiation generated by the source;

a reflective condenser that directs the ultraviolet radiation onto a sample at an

angle of between normal to the sample and 7 degrees off normal;

an aperture for spatially filtering the ultraviolet radiation;

an objective lens that forms an image of the ultraviolet radiation from the

sample; and

a spatially resolved detector for detecting the image of the sample formed by

the objective lens; and

An optical system as claimed in claim 9, wherein a virtual source of the extreme

ultraviolet radiation source formed by the condenser and a region of interest of the

target sample, which is a mask, reside on a Rowland circle determined by the

condenser.

15. (Original) An optical system as claimed in claim 9, wherein the detector is a

CCD camera.

16. (Original) An optical system as claimed in claim 9, wherein the detector is a

CMOS camera.

5 of 9

Application No.: 10/683,872 Amendment dated: March 27, 2007

Reply to Office Action of December 27, 2006 Attorney Docket No.: 0002.0004US1

17. (Currently amended) An optical system comprising:

an extreme ultraviolet radiation source;

a spectral filter that filters ultraviolet radiation generated by the source;

a reflective condenser that directs the ultraviolet radiation onto a sample at an angle of between normal to the sample and 7 degrees off normal;

an aperture for spatially filtering the ultraviolet radiation;

an objective lens that forms an image of the ultraviolet radiation from the sample; and

a spatially resolved detector for detecting the image of the sample formed by the objective lens; and

An optical system as claimed in claim 9, wherein the objective lens comprises an achromatic Fresnel optic with a silicon refractive lens.

- 18. (Original) An optical system as claimed in claim 9, wherein the source uses emission from a copper target.
- 19. (Currently amended) An optical system comprising:

an extreme ultraviolet radiation source;

a spectral filter that filters ultraviolet radiation generated by the source;

a reflective condenser that directs the ultraviolet radiation onto a sample at an angle of between normal to the sample and 7 degrees off normal;

an aperture for spatially filtering the ultraviolet radiation;

an objective lens that forms an image of the ultraviolet radiation from the sample; and

a spatially resolved detector for detecting the image of the sample formed by the objective lens; and

An optical system as claimed in claim 9, wherein the objective lens comprises an achromatic Fresnel optic with a refractive lens made from copper.

Application No.: 10/683,872

Amendment dated: March 27, 2007

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Attorney Docket No.: 0002.0004US1

20. (Previously presented) An optical system as claimed in claim 9, wherein the

objective lens comprises a zone plate lens.

21. (New) An optical system as claimed in claim 9, wherein the sample is a

lithography mask.

22. (New) An optical system as claimed in claim 9, wherein the ultraviolet

radiation has a wavelength of 13 to 14 nanometers and the objective comprises a

zone plate made from molybdenum (Mo).

23. (New) An optical system as claimed in claim 9, wherein the ultraviolet

radiation has a wavelength of 13 to 14 nanometers and the objective comprises a

zone plate made from niobium (Nb).

24. (New) An optical system as claimed in claim 9, wherein the ultraviolet

radiation has a wavelength of 13 to 14 nanometers and the objective comprises a

zone plate made from technetium (Tc).

25. (New) An optical system as claimed in claim 9, wherein the ultraviolet

radiation has a wavelength of 13 to 14 nanometers and the objective comprises a

zone plate made from ruthenium (Ru).

7 of 9